

Search Notes

Application/Control No.

10/654,168

Examiner

Ephrem Alemu

Applicant(s)/Patent under
Reexamination

DIVERGILIO ET AL.

Art Unit

2821

SEARCHED

| Class | Subclass | Date | Examiner |
|---------|-------------------------------|-----------|----------|
| 315 | 506, 505, 507, 501, 500 | 2/28/2005 | EA |
| 250 | 423-427 | 2/28/2005 | EA |
| 250 | 492.2 | 3/1/2005 | EA |
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| Updated | Search | 5/12/2005 | EA |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|-----------|----------|
| 315 | 505, 506 | 5/12/2005 | EA |
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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|--|-----------|------|
| Searched EAST Search Terms: Quadrupole lens electrode ion implantation undulator voltage supply unipolar bipolar switching | 2/28/2005 | EA |
| EAST | 5/12/2005 | EA |
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